

| | 2012/8/14 | 2012/8/15 | 2012/8/16 | 2012/8/17 | 2012/8/20 | 2012/8/21 | 2012/8/22-24 |
|-------------|-------------------------|-----------------------------------|-------------------------------------------------|-------------------------------------------|---------------------------------------------|----------------------------------------|--------------|
| 9:00-10:30 | lab tour at Hannover | move from Hannover to Jena | thermal noise lecture (D.Heinert) 10AM | TN lecture continues | bulk loss lecture (G.Hofmann) 10AM | absorption (Komma, Steinlechner) | lab work |
| 10:45-12:15 | | | | cooling time reduction (Sakakibara) | | suspension (Sekiguchi) | |
| 12:15-14:00 | | arrival & lunch | lunch | | | | |
| 14:00-15:30 | | lab tour & informal meeting | parametric instability (Shibata) | silicon cavity (Ushiba) | coating loss (Nawrodt) | free discussion | |
| 15:45-17:15 | | | thermal lensing (Michimura) | 120K Silicon (Somiya) | future topic (Matsumoto) | | |